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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Shunsuke SHUTOU et al.**

Group Art Unit: **2871**

Application Number: **10/544,208**

Examiner: **David C. NELMS**

Filed: **April 20, 2006**

Confirmation Number: **8467**

For: **RETARDATION FILM AND METHOD FOR PRODUCING THE
SAME**

Attorney Docket Number: **052820**

Customer Number: **38834**

INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. §1.97(b)

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

November 29, 2006

Sir:

In compliance with 37 C.F.R. §1.56, Applicants direct the attention of the Patent and Trademark Office to the documents listed on the attached PTO/SB/08. This paper is being filed within the time periods set forth in 37 C.F.R. §1.97(b). A copy of each non-U.S. document is enclosed herewith.

The documents are cited in the Office Action of the corresponding Korean patent application. JP 15-014928, cited in the Korean Office Action has already been disclosed in the Information Disclosure Statement filed August 2, 2005, and therefore is not listed in the attached PTO/SB/08.

If there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

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Enclosures: PTO/SB/08

Korean Office Action mailed Aug. 31, 2006 and 2 References



Combined Form PTO/SB/08A&B

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

Complete if Known

Application Number	10/544,208
Confirmation Number	8467
Filing Date	April 20, 2006
First Named Inventor	Shunsuke SHUTOU
Art Unit	2871
Examiner Name	David C. Nelms
Attorney Docket Number	052820

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of

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U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code ² (if known)		
	1	US 2003/0219549	A1	11-27-2003	Shimizu
	2	US 2002/0015807	A1	02-07-2002	Sugino et al.
		US			
		US			
		US			
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		US			
		US			
		US			

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Translation ⁶
		Country Code ³	Number ⁴	Kind Code ⁵ (if known)			
	3	KR	2003-88870	A	11-20-2003	Sumitomo Chem. Co., Ltd.	Abstract, Corrs. to 1
	4	KR	2001-113559	A	12-28-2001	Nitto Denko Corp.	Abstract Corrs. to 2

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation ⁶
	5	Office Action of Corresponding Korean Patent Application No. 10-2005-7012779 mailed Aug. 31, 2006	No

Examiner Signature

Date Considered

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² See Kind Codes of USPTO Patent Documents at www.uspto.gov, MPEP 901.04 or in the comment box of this document. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to indicate here if English language Translation is attached.